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## BIB DATA SHEET

CONFIRMATION NO. 4536

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/539,224	06/16/2005	438	2823	BE02 0043 US1	
<b>RULE</b>					
<b>APPLICANTS</b> Vincent Charles Venezia, Leuven, BELGIUM; Charles Johan Joachim Dachs, Leuven, BELGIUM; Jacob Christopher Hooker, Leuven, BELGIUM; Marcus Johannes Henricus Van Dal, Leuven, BELGIUM;					
<b>** CONTINUING DATA *****</b> Yes AKS 03/31/2008 This application is a 371 of PCT/IB03/06009 12/15/2003					
<b>** FOREIGN APPLICATIONS *****</b> None AKS 03/31/2008					
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b>					
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /ANKUSH K SINGAL/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance AKS Initials	<b>STATE OR COUNTRY</b> BELGIUM	<b>SHEETS DRAWINGS</b> 3	<b>TOTAL CLAIMS</b> 10	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> NXP, B.V. NXP INTELLECTUAL PROPERTY DEPARTMENT M/S41-SJ 1109 MCKAY DRIVE SAN JOSE, CA 95131 UNITED STATES					
<b>TITLE</b> Method of manufacturing a semiconductor device and semiconductor device obtained with such a method					
<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	